

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Application of:

Hiromichi Ohta, et al.

Application Serial No:
09/615,883

Filed July 14, 2000

TITLE: LOW-RESISTANCE ITO
THIN FILM AND METHOD FOR
MANUFACTURING SUCH A FILM

) Before the Examiner

) Jason Vincent V. de la Peña

) Group Art Unit 1775

) February 13, 2002

REQUEST FOR EXTENSION OF TIMECommissioner for Patents
Washington, D.C. 20231

Sir:

Applicant's attorney requests that the date for responding to the Office Action mailed August 14, 2001 for the above-referenced patent application be extended three months to and including February 14, 2002. The statutory fee for a large entity of \$920.00 for this request is enclosed herewith. The U.S. Patent and Trademark Office is authorized to charge any deficiency or apply any overpayment credit to Deposit Account No. 23-3030.

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231 on:

February 13, 2002
(Date of Deposit)

Vincent O. Wagner
Name of Registered Representative

Signature

February 13, 2002
Date of Signature

Respectfully submitted,

By: 

Vincent O. Wagner
Reg. No. 29,596
Woodard, Emhardt, Naughton,
Moriarty & McNett
Bank One Center/Tower
111 Monument Circle, Suite 3700
Indianapolis, Indiana 46204-5137
(317) 634-3456

COPY OF PAPER
ORIGINALLY FILED

RECEIVED
MAR - 7 2002
TC 1700